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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yoko SUZUKI et al.

Serial No. 10/000,304

Filed December 4, 2001

MAR 1 8 2002

Confirmation No. 8913

Attn: BOX MISSING PARTS

Docket No. 2001-1792A

SUBSTRATE TRANSPORT APPARATUS, POD AND METHOD

### PRELIMINARY AMENDMENT

Assistant Commissioner for Patents, Washington, DC 20231

Sir:

Prior to examination of the above-referenced U.S. patent application please amend the application as follows:

### IN THE DRAWINGS

Please replace drawing Figure 76 with the enclosed substitute drawing Figure 76.

## **REMARKS**

The present Preliminary Amendment is submitted to replace Figure 76.

Respectfully submitted,

Yoko SUZUKI et al.

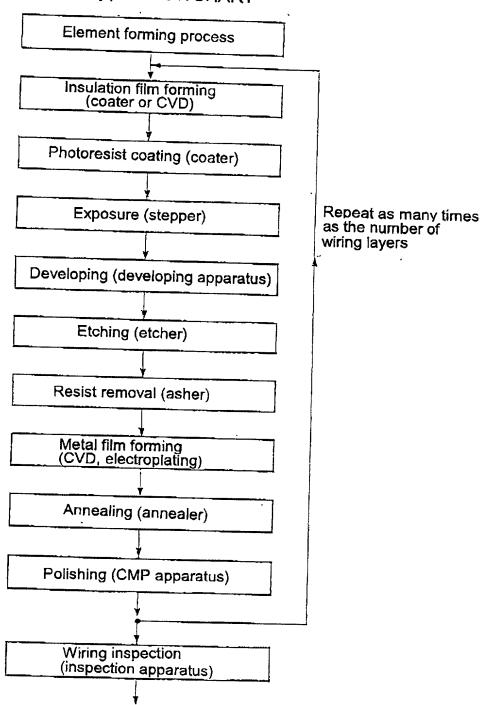
Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krl Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 March 18, 2002

# F1G.76.

# SEMICONDUCTOR MANUFACTURING PROCESS FLOWCHART



After forming insulation film and external terminals, sent to next processing